

FORM PTO-1449

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To be assigned**INFORMATION DISCLOSURE CITATION**

Applicant Toyohito ASAMURA et al.

Filing Date
HerewithGroup Art Unit
To be assigned**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
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	AG						
	AH						
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	AJ						
	AK						

JP973 U.S. PTO
10/026699
12/27/01

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
<i>uw</i>	AL	04-286736	10/1992	Japan	11		No
<i>uw</i>	AM	2000-82242	03/2000	Japan	11		No
	AN						
	AO						
	AP						

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

<i>uw</i>	AR		J. Hirokane et al., "An Etched Glass Master and a Photomask for an Optical Disk Substrate", International Progress In Precision Engineering, 1993, pps.542-553
	AS		
	AT		

Examiner

Date Considered

8/13/03

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